

ABSTRACT OF THE DISCLOSURE

This invention relates to an electrooptic system array having a plurality of electron lenses. The electrooptic system array includes upper, middle, and
5 lower electrodes arranged along the paths of a plurality of charged-particle beams, the upper, middle, and lower electrodes having pluralities of apertures on the paths of the plurality of charged-particle beams, an upper shield electrode which is interposed between
10 the upper and middle electrodes and has a plurality of shields corresponding to the respective paths of the charged-particle beams, and a lower shield electrode which is interposed between the lower and middle electrodes and has a plurality of shields corresponding
15 to the respective paths of the charged-particle beams.